

Dr. Thomas Miller



Tom gained a BSc in Computational Physics, followed by a PhD in thin film deposition, both at Nottingham Trent University. He joined Oxford Instruments in 2010 as Field Process Engineer which gave him a broad knowledge of multiple customer systems and processes.

His work now focuses on ICPCVD, PECVD, and PE-ALD and has expanded recently to working on the Nanofab tool and its related processes.